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Large Mirrors and Telescopes

Myung K. Cho
Bin Fan
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Contents

- vii *Authors*
- ix *Symposium Committees*
- xi *Introduction*
- xiii *Sponsors*

ORAL SESSION

- 9682 02 **Progress in the indirect slumping technology development at MPE for lightweight x-ray optics (Invited Paper) [9682-10]**
- 9682 03 **Design and analysis of a 2-DOF RFM for the mirror sub-assembly (MSA) of ICF facility [9682-54]**
- 9682 04 **Study on the temperature field effect analysis and test of the five-hundred-meter aperture spherical radio telescope [9682-31]**
- 9682 05 **Gravity and thermal deformation of large primary mirror in space telescope [9682-28]**
- 9682 06 **Research on new-style flexure supports method for large-aperture transport mirror mounting [9682-38]**
- 9682 07 **Modeling and control of the driving system of slant mount telescopes [9682-35]**
- 9682 08 **Hydraulic supports for polishing TMT M3MP [9682-45]**
- 9682 09 **Fabrication and metrology study for M3MP of TMT [9682-50]**
- 9682 0A **Research on sub-surface damage and its stress deformation in the process of large aperture and high diameter-to-thickness ratio TMT M3MP [9682-44]**

POSTER SESSION

- 9682 0B **Research on determination of operating posture of a complicated opto-mechanical structure [9682-52]**
- 9682 0C **A method on error analysis for large-aperture optical telescope control system [9682-7]**
- 9682 0D **Stability design of support systems in ICF lasers [9682-46]**
- 9682 0E **Analysis and design of coaxial three-mirror anastigmat with long effective focal length and full two-dimensional field [9682-116]**

- 9682 OF **Design of space-borne imager with wide field of view based on freeform aberration theory** [9682-6]
- 9682 OG **Field precision machining technology of target chamber in ICF lasers** [9682-47]
- 9682 OH **Design and simulation of adaptive optics controller based on mixed sensitivity H_{∞} control** [9682-12]
- 9682 OI **Influence of frequency on sub-mirror apertures and the surrounded apertures for the Golay3 sparse aperture** [9682-16]
- 9682 OJ **Joint of back-support in large aperture transport mirrors** [9682-49]
- 9682 OK **Spot detection based on the Hartmann subaperture** [9682-40]
- 9682 OL **Optical design of free-form surface two-mirror telescopic objective with ultrawide field of view** [9682-11]
- 9682 OM **Development status on the real-time controller for solar multi-conjugate adaptive optics system** [9682-37]
- 9682 ON **Study on geometric performance assessment method of high resolution optical remote sensing satellite imagery** [9682-4]
- 9682 OO **Fabrication of large-aperture, high efficiency, Fresnel diffractive membrane optic for space telescope** [9682-14]
- 9682 OP **Estimating the point spread function of an imaging system using wavefront measurement** [9682-19]
- 9682 OQ **Analysis of surface error correction capability of 1.2m active support system** [9682-36]
- 9682 OR **Structural design of 3m class ground based telescope elevation ring** [9682-22]
- 9682 OS **Design of incomplete derivative fuzzy PID control system for fast-steering mirror** [9682-29]
- 9682 OT **Thermal blooming on laser propagation in an aspirating pipe** [9682-26]
- 9682 OU **Misalignment induced aberration off-axis optical system** [9682-32]
- 9682 OV **Simulation of co-phase error correction of optical multi-aperture imaging system based on stochastic parallel gradient decent algorithm** [9682-24]
- 9682 OW **Multi-spectral modulation detection of co-phasing errors for sparse-optical-synthetic-aperture systems** [9682-23]
- 9682 OX **Study on the support technology of the light-weighted mirror** [9682-30]
- 9682 OY **Incoherent coincidence imaging of space objects** [9682-18]
- 9682 OZ **Modern methods of production of large-sized multicomponent optical systems** [9682-9]

- 9682 10 **Analysis of offset error for segmented micro-structure optical element based on optical diffraction theory** [9682-27]
- 9682 11 **Feasibility of multi-detector intensity correlation imaging method for space object** [9682-21]
- 9682 12 **Design of efficient and simple interface testing equipment for opto-electric tracking system** [9682-39]
- 9682 13 **Integrated opto-mechanical optimization analysis of large-aperture primary mirror's support position** [9682-20]
- 9682 14 **Study on rejection characteristic of current loop to the base disturbance of optical communication system** [9682-41]
- 9682 15 **Switch-zoom optical system design of large aperture ground-based photoelectric detection** [9682-13]
- 9682 16 **Research of centroiding algorithms for extended and elongated spot of sodium laser guide star** [9682-34]
- 9682 17 **Study of image motion compensation in spectral imaging system** [9682-33]
- 9682 18 **Alignment method of off-axis RC reflective optical system** [9682-43]
- 9682 19 **Research for diagnosing electronic control fault of astronomical telescope's armature winding by step signal** [9682-42]
- 9682 1A **The application of pentaprism scanning technology on the manufacturing of M3MP** [9682-51]

Authors

Numbers in the index correspond to the last two digits of the six-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first four digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Ai, Zhiwei, 0S, 0T, 0X
Baoqi, Mao, 0E
Belousov, Sergey P., 0Z
Breunig, Elias, 02
Burwitz, Vadim, 02
Cai, Ziyuan, 07
Cao, Zheng, 14
Chen, Baohua, 0I
Chen, Gang, 03, 0D, 0G
Chen, Qian, 0Y
Chen, Xiaojuan, 03, 0B, 0D, 0J
Chen, Xing Long, 17
Chen, Zhongfeng, 0K
Cole, Glen, 08, 09, 0A, 1A
Deng, Chao, 12, 14
Domnin, Aleksandr V., 0Z
Dong, Li, 0W
Duan, Jing, 15
Duan, Lin, 0G
Fan, Bin, 0Q
Fan, Junlin, 0I
Fan, Xuewu, 0U
Feng, Lingjie, 11
Ford, Virginia G., 08, 09, 1A
Friedrich, Peter, 02
Fu, Ruimin, 0N
Fu, Shaojun, 0O
Fu, Xuenong, 03
Galyavov, Igor R., 0Z
Gao, Xin, 11
Gu, Bozhong, 19
Gu, Guohua, 0Y
Han, Yu, 0Q
He, Hongyan, 0N
He, Weiji, 0Y
He, Xiaojun, 0V
Hou, Xiao-hua, 18
Hu, Hai-fei, 08, 09, 0A, 1A
Hu, Hai-xiang, 08, 09, 0A, 1A
Huang, Qiaolin, 0N
Huang, Yongmei, 0C
Huang, Zhan, 0B
Huang, Zongfu, 0P
Ignatov, Aleksandr N., 0Z
Jiang, Bian, 13
Jiang, Chuan, 0R
Jiang, Hui, 0I
Jiang, Huilin, 0F
Jiang, Kai, 15
Jiang, Pengzhi, 0P
Jiang, Shouwang, 05
Jiao, Jianchao, 0O
Jin, Yangming, 0L
Ke, Ding, 13
Kong, Lin, 0M
Li, Chaoqiang, 0Q
Li, Mengjuan, 0O
Li, Xinyang, 0H
Li, Xiyu, 11
Li, Zhijun, 17
Liang, Yonghui, 0P
Lin, Han, 0E
Liu, Changchun, 06, 0J
Liu, Haitao, 0Q
Liu, Huilin, 0G
Liu, Jin, 0P
Liu, Kai, 15
Liu, Qinghan, 0L
Liu, Qiong, 12, 14
Liu, Xiang, 0C
Liu, Zhengkun, 0O
Lu, Zhiyi, 0I
Luo, Chuanxin, 0V
Luo, Xiao, 08, 09, 0A, 1A
Ma, Haotong, 0V, 0W
Ma, Zhen, 0U
Madarasz, Emanuel, 02
Mao, Hongjun, 0P
Mao, Tianyi, 0Y
Mao, Yao, 12, 14
Pang, Zhihai, 0U
Peng, Qi, 0W
Peng, Zhenming, 0H
Ponin, Oleg V., 0Z
Proserpio, Laura, 02
Qi, Bo, 0X, 13
Qi, Erhui, 08, 09, 0A, 1A
Quan, Xusong, 06
Que, X. H., 0J
Rao, Changhui, 0M
Ren, Ge, 0R, 0S, 0T, 0X
Shan, Qiusha, 15
Shao, Yayun, 16
Sharov, Aleksandr A., 0Z
Shen, Weimin, 0L
Shi, Haodong, 0F
Shi, Sucun, 0G
Shu, Rong, 05

Song, Dingan, 0H
Song, Li-qiang, 04
Song, Yugang, 0G
Su, Jinyan, 10
Su, Ruifeng, 0B
Su, Yanrui, 0C
Tan, Yi, 0S
Tan, Yufeng, 0R, 0S, 0T
Tian, Jing, 12
Tian, Yan, 07
Wan, Jinlong, 05
Wang, Baoxu, 03, 0B, 0G, 0J
Wang, Hui, 06
Wang, Jihong, 0R, 0T
Wang, Lihua, 10
Wang, Lingjie, 0F
Wang, Qiang, 0C
Wang, Qi-ming, 04
Wang, Xin, 05
Wang, Ya, 07
Wang, Zhipeng, 0W
Wei, Kai, 16
Weimin, Shen, 0E
Wen, Mingwu, 02
Wen, Sun, 0E
Wu, Qiongyan, 0S
Wu, Quanying, 0I
Wu, Shibin, 10
Wu, Wenkai, 0B, 0D, 0G, 0J
Xia, Zhongqiu, 0N
Xie, Zongliang, 0R, 0W
Xing, Song, 18
Xiong, Zhao, 06
Xu, Xiangdong, 0O
Xu, Yuanli, 0D, 0G
Xue-min, Zhang, 18
Yan, Fabao, 0C
Yan, Peipei, 15
Yang, Shihai, 19
Yang, Wei, 10
Yin, Ganghua, 0O
Yuan, Xiaodong, 06
Yue, Chunyu, 0N
Zhan, H., 0D
Zhang, Jian, 0O
Zhang, Jizhen, 0F
Zhang, Xin, 0F
Zhang, Xue-jun, 08, 0A, 1A
Zhang, Yudong, 16
Zhang, Yulong, 19
Zhang, Zheng, 06
Zhi-jun, Zhang, 18
Zhou, Luchun, 0K
Zhou, Wangping, 07
Zhou, Zhengping, 0L
Zhu, Fuyin, 0R, 0S, 0T, 0X
Zhu, Lei, 0M
Zhu, Mingzhi, 03, 0B, 0D, 0G, 0J
Zhu, Nengbing, 0S, 0T, 0X
Zou, Gangyi, 0U

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Introduction

The 8th International Symposium on Advanced Optical Manufacturing and Testing Technology (AOMATT 2016) was held 26–29 April 2016 at the Suzhou International Conference Center, Suzhou, China. The symposium was opened in the morning of 26th April with a formal opening ceremony. The ceremony started with the introduction of VIP guests, symposium chairs, conference chairs, and plenary speakers. Professor Liwei Zhou AOMATT 2016 Symposium Chairman, Professor Bin Xu Vice President of Institute of Optics and Electronics (China), one of the sponsors of AOMATT 2016, and Professor Yuan Yinnan, Vice President of Soochow University (China) gave opening speeches to a packed auditorium.

Plenary sessions followed immediately after the conclusion of the opening ceremony. There were a total of eight plenary presentations: "Less is more: extreme optics with zero refractive index physics", by Dr. Eric Mazur, Balkanski Professor of Physics and Dean of Applied Physics at Harvard University (United States); "Large optical telescopes in the era of large wide-field survey", by Dr. David R. Silva, Director of United States National Optical Astronomy Observatory (United States); "The European Extremely Large Telescope (E-ELT) revolution is under construction", by Dr. Marc Cayrel, European Southern Observatory (ESO) Project Manager, E-ELT Optomechanics (Germany); "Ultra-precision lens fabrication via molding: advances and challenges", by Dr. Liangchi Zhang, Professorial Fellow of Australian, Head of the Laboratory for Precision and Nano Processing Technologies, The University of New South Wales (Australia); "Advancing ultra-precision machining to high performance", by Dr. Ing. Oltmann Riemer, Head of the Laboratory for Precision Machining, Universität of Bremen (Germany); "Micro/nano-optics for flexible functional devices: today and future", by Dr. Linsen Chen, Chief of National United Engineering Research Center of Digital Optical Imaging and Display, Soochow University (China); "New angles on angle metrology: approaching fundamental limits", by Dr. Ralf D. Geckeler, Head of Length and Angle Graduations Group, Physikalisch-Technische Bundesanstalt (Germany); and "Functional photonic nanostructures: from thin films and slits to catenaries", by Dr. Xiangang Luo, Director of State Key Laboratory of Optical Technologies for Nano-Fabrication and Micro-Engineering, Chinese Academy of Sciences (China).

More than 800 people attended the opening ceremony and full-day plenary sessions. More than 1,000 abstracts were submitted to AOMATT 2016. About 500 submissions were selected for oral and poster presentations after careful reviews by conference chairs and committee members. Oral papers were presented in eight parallel conference sessions 27 and 28 April. An all-symposium poster session was held in the afternoon of 28 April. Many papers highlighted cutting edge research and development in optical design, manufacturing, and testing. Authors and attendees had very productive discussions and exchanged ideas throughout the symposium.

The AOMATT 2016 organizing committee would like to express their sincere appreciation for the strong support of SPIE, technical co-sponsor and long-term partner of AOMATT. Dr. Andrew Brown, Senior Director of SPIE, sent a letter of congratulations to the symposium. In his letter, Dr. Brown thanked all symposium chairs, conference chairs, and committee members for their leadership, and all authors and attendee for their contributions to make AOMATT 2016 a success. Dr. Brown also stated: "The vision of AOMATT is closely aligned with SPIE's mission to promote optics and photonics around the world. SPIE sponsors and co-sponsors technical conferences around the world and contribute millions of dollars every year in support of education and outreach programs, such as scholarships, travel grants, and other educational programs."

Finally, we would like to express our sincere appreciation to COS—The Chinese Optical Society (China), and IOE—Institute of Optics and Electronics, Chinese Academy of Sciences (China), for sponsoring and supporting AOMATT 2016. We want to thank all authors and participants as well volunteers for their contributions to the symposium and sharing their research with colleagues around the world.

We look forward to seeing everyone at AOMATT 2018.

Li Yang
Secretary General, AOMATT 2016
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